

Mechanoluminescent materials and their applications

応力発光材料の開発と応用

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Recently, we developed innovative elasticoluminescent (ESL) materials, each particle of which repeatedly emits visible light in response to stress. Distinct from other kinds of mechanoluminescence (ML), the ESL is reproducible by mechanical stimulation. When a structure is coated with such a material, each particle acts as a sensitive mechanical sensor, and the two-dimensional emission pattern of the entire assembly represents an accurate reflection of the dynamical strain (stress) distribution of the structure.¹⁻⁶⁾

This novel approach enables diagnostics of structural health, with a number of advantages over the conventional point-by-point measurement method using a strain gauge. With the proposed technique, defects invisible with the naked eye and microscopic cracks in small parts of machinery can be detected, and the safety of largescale constructions such as bridges can be monitored with respect to various types of vibration and damage. In this manner, the use of the proposed ESL technology is expected to pave the way for novel methods for structural health diagnosis.⁷⁻¹⁸⁾

We have confirmed that the ESL intensity distribution is in excellent agreement with the distribution of equivalent stress and the distribution of strain/deformation energy, which are related to damage, even under complex conditions. Also, a comparison between the measured stress values and the safety standard values can aid the process of elucidating the level of danger imposed by defects.

By covering the entire target area under observation, measurements and inspections based on ESL can reveal localized cracks emerging in this area and can provide a high-resolution representation of the corresponding strain/stress distribution and danger level.

This is one of the main characteristics of ESL-based technology, which is expected to provide the basis of not only new methods for stress analysis, but also an entire new industry centered on the inspection of structural safety.

Here, we show the example of visualization of ultrasonic power distribution. The ultrasonic power

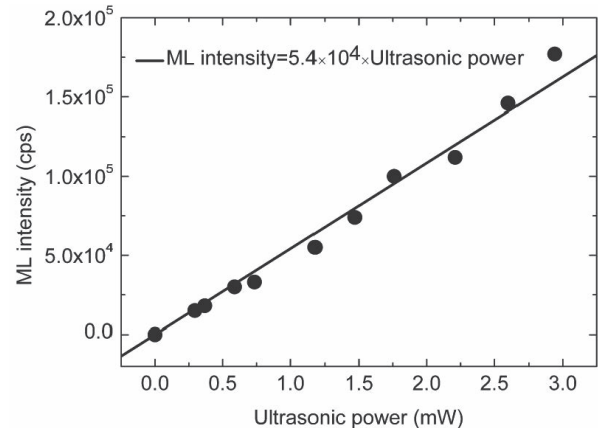


Fig. 1 Relationship between ML intensity and ultrasonic output power.

is not distributed uniformly over the area of an ultrasonic pulse. Therefore, with respect to potential biological effects of the ultrasonic wave including thermal effect and cavitations, it is not sufficient to measure only the total output power of the transducer so that, the measurement of ultrasonic output power distribution is also of great significance. However, it has been difficult to do such measurements by conventional methods. In this study, two transducers with different frequency and shape were used to produce ultrasonic vibration; a CCD camera was used to record ML images during the application of ultrasonic vibration to the ML film. A luminescent region on the ML sensing film was observed during the application of ultrasonic vibration, the shape and size of the region was the same as that of the piezoelectric ceramic patch of the transducer, as shown in **Fig. 2(a) and (b)**. The distribution of ML intensity along the X-axis is plotted in **Fig. 2(c)**. In order to visualize the distribution of ultrasonic power density, a calibration curve between the grayscale value of the image and the power density was constructed according to the relationship shown in **Fig. 1**.

Figure 3 shows the three-dimensional representation of the ultrasonic output power distribution. As shown in this figure, the distribution of ultrasonic output power was near a normal distribution; the power density in the central area was the largest. By comparison the output power of the transducer with 6 MHz was only about one fifth of that of the transducer with 20 MHz.

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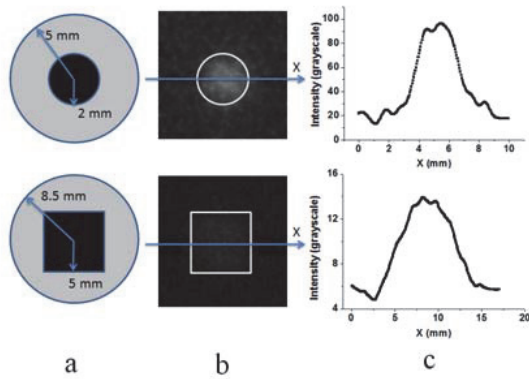


Fig 2. (a) Cross-sectional view of the transducers (Outer: epoxy resin; central: piezoelectric ceramic patch). (b) ML images recorded during ultrasonic vibration. (c) Distribution of ML intensity along X-axis. (Up: 20 MHz; below: 6 MHz)

approach, the ultrasonic output power distribution of the transducer could be visualized simply and directly by measuring the ML distribution.

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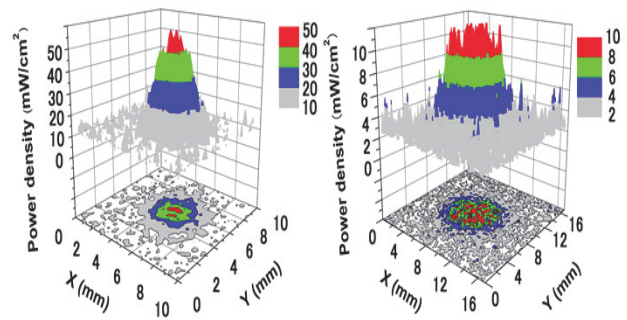


Fig 3. Three-dimensional representation of ultrasonic output power distribution of two transducers. (Left: 20 MHz; right: 6 MHz)

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